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Holladay et al.Filing Date
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1754

U.S. Patent Documents

Examiner Initial		Patent Number	Date	Name	Class	Sub-Class	Filing Date
<i>ju</i>	AA	6,277,339	8/21/2001	Bonberg et al.	422	198	7/19/99
	AB	6,192,596	2/27/2001	Bennett et al.	34	76	
	AC	6,117,578	9/12/2000	Lesieur et al.	429	19	
	AD	5,858,314	01/1999	Hsu et al.	422	211	
	AE	5,432,023	07/1995	Yamada et al.	429	34	
<i>ju</i>	AF	4,876,162	10/1989	McElroy	429	13	
	AG						

Foreign Patent Documents

		Document Number	Date	Country	Class	Sub-Class	Translation
<i>ju</i>	AH	WO 02/064248A3	08/2002	PCT	B01J	19/00	
	AI	WO 00/79199 A1	12/28/2000	PCT	F28D	7/00	
	AJ	WO 00/06295	2/10/2000	PCT	B01J	12/00	
	AK	EP 1031374A3	8/30/2000	Europe	B01J	8/02	No
	AL	EP 0921584 A3	06/1999	Europe	H01M	8/06	No
	AM	EP 1087455 A2	3/28/2001	Europe	H01M	8/04	
<i>ju</i>	AN	EP 0308976 A1	03/1989	Europe	C01B	3/34	
	AO						
	AP						

Other Documents (Including Author, Title, Date, Pertinent Pages, etc.)

<i>ju</i>	AQ	PCT Search Report, mailed Oct 24, 2003, PCT/US 02/35762
<i>ju</i>	AR	Schubert et al., "Microstructure Devices For Applications In Thermal And Chemical Process Engineering," Microscale Thermophysical Engineering, 5:17-39, 2001.
	AS	
	AT	

Examiner

Josh C. [Signature]

Date Considered

8/4/04

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.